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Patent

Case No.: 57322US0026

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: BAUDE, PAUL F.

Application No.: 10/076174 Group Art Unit: 1756

Filed: February 14, 2002 Examiner: Unknown

Title: APERTURE MASKS FOR CIRCUIT FABRICATION

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on:

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Signed by: Lydia M. Cahill

Lydia M. Cahill

Dear Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, enclosed please find a completed PTO-1449 form citing references submitted for consideration during examination of the above-referenced patent application. A copy of each of the references cited therein is also enclosed.

It is respectfully requested that the Examiner initial and return the enclosed PTO-1449 form in order to indicate that each of the references listed thereon has been considered in connection with the present application.

Respectfully submitted,

May 14, 2002
Date

By:

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Application Number

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First Named Inventor

Baude, Paul F.

Art Unit

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Examiner Name

Attorney Case Number

57322US002

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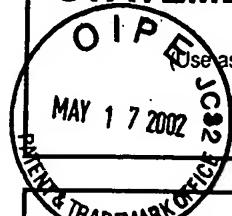
OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
	C4	Schon et al., "Fast Organic Electronic Circuits Based on Ambipolar Pentacene Field-Effect Transistors," Applied Physics Letters, Vol. 79, No. 24, pp. 4043-4044 (2001),
	C5	Gouy et al., "Deposition of Organic Semiconductor Through Silicon Shadow Masks for Integrated Led on Silicon."
	C6	Kim et al., "Photoplastic Shadow-Masks for Rapid Resistless Multi-Layer Micropatterning".
	C7	Kim et al., "Dry-Lift-Off Patterning on Fragile Surfaces Using MEMS Shadow Masks," pp. 619-622.

*Examiner:

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Filing Date

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First Named Inventor

Baude, Paul F.

Art Unit

1756

Examiner Name

Attorney Case Number

57322US002

U.S. Patent Documents

Exam. Init.*	Cite No.	Document Number	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Doc. Number-(Kind Code if Known)			
	A1	US- 3,669,060	06/13/72	Page et al.	
	A2	US- 4,096,821	06/27/78	Greeneich et al.	
	A3	US- 4,335,161	06/15/82	Luo	
	A4	US- 4,676,193	06/30/87	Martin	
	A5	US- 4,746,548	05/24/88	Boudreau et al.	
	A6	US- 4,915,057	04/10/90	Boudreau et al.	
	A7	US- 4,963,921	10/16/90	Kariya et al.	
	A8	US- 5,397,607	03/14/95	Shields et al.	
	A9	US- 6,087,196	07/11/00	Sturm et al.	
	A10	US- 6,106,627	08/22/00	Yializis	
	A11	US- 6,285,001 B1	09/04/01	Fleming et al.	

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Foreign Patent Documents

Exam. Init.*	Cite No.	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation (Check if yes)
		Ctry. Code	Number-KindCode (if known)				
	B1	EP	0 118 576	12/02/87			
	B2	EP	0719 638 A2	07/03/96			
	B3	JP	5-228669	09/07/93			X
	B4	JP	9-27454	01/28/97			X
	B5	PCT	WO 99/30336	06/17/99			
	B6	PCT	WO 99/39373	08/05/99			
	B7	PCT	WO 99/54786	10/28/99			

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
	C1	Brody, "Large Area Masking Techniques for Thin Film Transistor Arrays," SPIE, Vol. 100, Semiconductor Microlithography II, pp. 140-150(1977)
	C2	Weimer, "The TFT- A New Thin-Film Transistor," Proceedings of the IRE, pp. 1462-1469(1962).
	C3	Brody et al., "Flexible Thin-Film Transistors Stretch Performance, Shrink Cost," Research, pp. 20-23 (1969).

*Examiner:

Date Considered:

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